

18334 U.S. PTO
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September 12, 2003

03970 U.S. PTO
10/660490
09/12/03

Box: PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attorney Reference: OHG 135

Re: New Patent Application of: Noriko TOMITA & Takashi OHSAKO
Title: SEMICONDUCTOR SUBSTRATE SURFACE PROTECTION METHOD

Sir:

Please find attached hereto an application for patent which includes:

- Specification, Claims and Abstract (15 Pages)
- 2 Sheets of Formal Drawings (Fig. 1 through Fig. 4)
- Inventor's Declaration and Power of Attorney (3 Pages)
- Assignment document with cover page (3 Pages)
- Claim for priority and the Priority document
- Information Disclosure Statement, PTO-1449 with 2 references
- Credit Card Form PTO-2038
- Fee (see formula below)

Basic Fee \$750/375 \$ 750.00

Additional Fees:

Total number of claims: 18 \$ 0.00
in excess of 20: 0 times \$18/9

Number of independent claims: 3 \$ 0.00
in excess of 3: 0 times \$84/42

Multiple Dependent Claims \$280/140 \$ 0.00

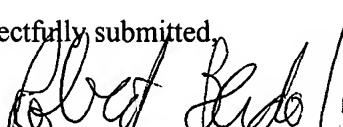
Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ 790.00

In the event there is attached hereto no form PTO-2038, check, or a check for an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2002-298452, filed October 11, 2002.

Respectfully submitted,


Robert H. Berdo, Jr.
Registration No. 38,075
Customer No. 23995

September 12, 2003

Date

RHB:crh